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- (d) As an alternative standard, the owner or operator of an existing or new affected source may comply with the storage tank standards by routing storage tank vents to a control device achieving an outlet TOC concentration, as calibrated on methane or the predominant HAP, of 20 ppmv or less, and an outlet concentration of hydrogen halides and halogens of 20 ppmv or less. Compliance with the outlet concentrations shall be determined by the initial compliance procedures of §63.1257(c)(4) and the continuous emission monitoring requirements of §63.1258(b)(5).
- (e) Planned routine maintenance. The specifications and requirements in paragraphs (b) through (d) of this section for control devices do not apply during periods of planned routine maintenance. Periods of planned routine maintenance of the control devices, during which the control devices not meet the specifications of paragraphs (b) through (d) of this section, as applicable, shall not exceed 240 hours per year.

#### § 63.1254 Standards: Process vents.

(a) Existing sources. Except as provided in paragraph (c) of this section, the owner or operator of an existing affected source must control the collection of all gas streams originating from processes subject to this standard so as to comply with the requirements in paragraph (a)(1) or the requirements of paragraphs (a)(2) and (a)(3) of this section. If any vent within a process meets the criteria of paragraph (a)(3)(i) of this section, the owner or operator must comply with the provisions in paragraphs (a)(2) and (a)(3) for that process. The requirements of paragraphs (a) (1) and (2) of this section apply to all process vents within a process, as a group, and do not apply to individual vents. An owner or operator may switch from compliance with paragraph (a)(1) of this section to compliance with paragraphs (a) (2) and (3) of this section only after at least 1 year of operation in compliance with paragraph (a)(1) of this section. An owner or operator may switch from compliance with paragraphs (a) (2) and (3) of this section to compliance with paragraph (a)(1) of this section at any time. Notification of such a change in the

- compliance method shall be reported according to the procedures in §63.1260(h) of this subpart. Compliance with the required emission limits or reductions in paragraphs (a) (1) through (3) of this section may be demonstrated using the initial compliance procedures described in §63.1257(d) and the monitoring requirements described in §63.1258.
- (1) Except for processes with a vent that meets the conditions in paragraph (a)(3)(i) of this section, actual HAP emissions shall not exceed 900 kilograms (kg) per year [2,000 pounds per year] from the sum of all process vents within a process.
- (i) Except as provided in paragraph (a)(1)(ii) of this section, the owner or operator is limited to 7 processes in any 365-day period that can be selected to comply with paragraph (a)(1) of this section.
- (ii) The owner or operator may exclude processes with less than 100~lb/yr HAP, on an uncontrolled basis, from the 7-process limit described in paragraph (a)(1)(i) of this section.
- (2) Uncontrolled HAP emissions from the sum of all process vents within a process that do not meet the conditions in paragraph (a)(3)(i) of this section or are not controlled according to any of the requirements of paragraphs (a)(2)(i), (a)(2)(ii), (a)(2)(iii), or (c) of this section shall be reduced by 93 percent or greater by weight.
- (i) To outlet concentrations less than or equal to 20 ppmv as TOC and less than or equal to 20 ppmv as hydrogen halides and halogens;
- (ii) By a flare that meets the requirements of §63.11(b); or (iii) By a control device specified in §63.1257(a)(4).
- (3) Except as provided in paragraph (a)(3)(iii) of this section, uncontrolled HAP emissions from each process vent that meets the conditions in paragraph (a)(3)(i) of this section shall be reduced as specified in paragraph (a)(3)(ii) of this section.
- (i) Uncontrolled HAP emissions from a process vent shall be reduced as specified in paragraph (a)(3)(ii) if the vent meets either of the criteria described in paragraph (a)(3)(i) (A) or (B) of this section:
- (A) The flow-weighted average flowrate calculated using Equation 1 of

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this subpart is less than or equal to the flowrate calculated using Equation 2 of this subpart.

$$FR_{a} = \frac{\sum_{i=1}^{n} (D_{i})(FR_{i})}{\sum_{i=1}^{n} D_{i}}$$
 (Eq. 1)

$$FR = 0.02 * (HL) - 1,000$$
 (Eq. 2)

Where:

 $FR_a = flow\text{-weighted average flow} \\ for the vent, scfm$ 

 $D_i$  = duration of each emission event, min

 $FR_i = flowrate \ of \ each \ emission \ event, \\ scfm$ 

n = number of emission events

FR = flowrate, scfm

HL = annual uncontrolled HAP emissions, lb/yr, as defined in §63.1251

- (B) As an alternative to the criteria described in paragraph (a)(3)(i)(A) of this section, uncontrolled HAP emissions from a process vent shall be reduced or controlled as specified in paragraph (a)(3)(ii) of this section if the process vent meets the criteria specified in paragraphs (a)(3)(i)(B)(1) and (2) of this section or the criteria specified in paragraphs (a)(3)(i)(B)(1) and (3) of this section.
- (1) Uncontrolled HAP emissions from the process vent exceed 25 tons per year.
- (2) The flow-weighted average flowrate for the vent, as calculated in Equation 1 of this section, is less than or equal to 100 scfm.
- (3) The flow weighted average is greater than 100 scfm and less than or equal to the flowrate calculated using Equation 2 of this section.
- (ii) Uncontrolled HAP emissions shall be reduced:
- (A) By 98 percent by weight or greater; or
- (B) To outlet concentrations less than or equal to 20 ppmv as TOC and less than or equal to 20 ppmv as hydrogen halides and halogens; or
- (C) By a flare that meets the requirements of §63.11(b); or
- (D) By a control device specified in §63.1257(a)(4).

- (iii) If the owner or operator can demonstrate that a control device, installed on a process vent that meets the conditions of paragraph (a)(3)(i) of this section on or before April 2, 1997, was designed to reduce uncontrolled HAP emissions of total HAP by greater than or equal to 93 percent by weight, but less than 98 percent by weight, then the control device is required to be operated to reduce inlet emissions of total HAP by 93 percent by weight or greater.
- (b) New sources. Uncontrolled HAP emissions from the sum of all process vents within a process at a new affected source that are not controlled according to any of the requirements of paragraphs (b)(1), (2), or (3) of this section or paragraph (c) of this section shall be reduced by 98 percent or greater by weight if the uncontrolled HAP emissions from the sum of all process vents within a process is greater than 180 kg/yr (400 lb/yr). Compliance with the required emission limit or reduction is demonstrated using the initial compliance procedures in §63.1257(d) and the monitoring requirements described in §63.1258.
- (1) To outlet concentrations less than or equal to 20 ppmv as TOC and less than or equal to 20 ppmv as hydrogen halides and halogens;
- (2) By a flare that meets the requirements of §63.11(b); or
- (3) By a control device specified in  $\S63.1257(a)(4)$ .
- (c) As an alternative standard, the owner or operator of an existing or new affected source may comply with the process vent standards by routing all vents from a process to a control device achieving an outlet TOC concentration, as calibrated on methane or the predominant HAP, of 20 ppmv or less, and an outlet concentration of hydrogen halides and halogens of 20 ppmv or less. Any process vents within a process that are not routed to this control device must be controlled in accordance with the provisions of paragraphs (a)(2),(a)(3), and (b) of this section, as applicable. Compliance with the outlet concentrations shall be determined by the initial compliance procedures described in §63.1257(d)(1)(iv)

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and the continuous emission monitoring requirements described in §63.1258(b)(5).

## §63.1255 Standards: Equipment leaks.

- (a) General Equipment Leak Requirements. (1) The provisions of this section apply to pumps, compressors, agitators, pressure relief devices, sampling connection systems, open-ended valves or lines, valves, connectors, instrumentation systems, control devices, and closed-vent systems required by this subpart that are intended to operate in organic hazardous air pollutant service 300 hours or more during the calendar year within a source subject to the provisions of this subpart.
- (2) Consistency with other regulations. After the compliance date for a process, equipment subject to both this section and either of the following will be required to comply only with the provisions of this subpart:
  - (i) 40 CFR part 60.
  - (ii) 40 CFR part 61.
  - (3) [Reserved]
- (4) The provisions in §63.1(a)(3) of subpart A of this part do not alter the provisions in paragraph (a)(2) of this section.
- (5) Lines and equipment not containing process fluids are not subject to the provisions of this section. Utilities, and other nonprocess lines, such as heating and cooling systems which do not combine their materials with those in the processes they serve, are not considered to be part of a process.
- (6) The provisions of this section do not apply to bench-scale processes, regardless of whether the processes are located at the same plant site as a process subject to the provisions of this subpart.
- (7) Each piece of equipment to which this section applies shall be identified such that it can be distinguished readily from equipment that is not subject to this section. Identification of the equipment does not require physical tagging of the equipment. For example, the equipment may be identified on a plant site plan, in log entries, or by designation of process boundaries by some form of weatherproof identification. If changes are made to the affected source subject to the leak detection requirements, equipment identi-

fication for each type of component shall be updated, if needed, within 15 calendar days of the end of each monitoring period for that component.

- (8) Equipment that is in vacuum service is excluded from the requirements of this section.
- (9) Equipment that is in organic HAP service, but is in such service less than 300 hours per calendar year, is excluded from the requirements of this section if it is identified as required in paragraph (g) (9) of this section.
- (10) When each leak is detected by visual, audible, or olfactory means, or by monitoring as described in §63.180(b) or (c), the following requirements apply:
- (i) A weatherproof and readily visible identification, marked with the equipment identification number, shall be attached to the leaking equipment.
- (ii) The identification on a valve or connector in light liquid or gas/vapor service may be removed after it has been monitored as specified in paragraph (e)(7)(iii) of this section and §63.174(e), and no leak has been detected during the follow-up monitoring.
- (iii) The identification on equipment, except on a valve or connector in light liquid or gas/vapor service, may be removed after it has been repaired.
- (b) References. (1) The owner or operator of a source subject to this section shall comply with the following sections of subpart H, except for §63.160, §63.161, §63.162, §63.163, §63.167, §63.168, §63.170, §63.171, §63.172, §63.173, §63.181, and §63.182 of this subpart. In place of §63.160 and §63.162, the owner or operator shall comply with paragraph (a) of this section; in place of §63.161, the owner or operator shall comply with §63.1251 of this subpart; in place of §63.163 and §63.173, the owner or operator shall comply with paragraph (c) of this section; in place of §63.167, the owner or operator shall comply with paragraph (d) of this section; in place of §63.168, the owner or operator shall comply with paragraph (e) of this section; in place of §63.170, the owner or operator shall comply with §63.1254 of this subpart; in place of §63.171, the owner or operator shall comply with paragraph (b)(1)(v) of this section; in place of §63.172, the owner or operator